

<b>Notice of References Cited</b>	Application/Control No. 10/666,317	Applicant(s)/Patent Under Reexamination MUI ET AL.	
	Examiner Eric B. Chen	Art Unit 1765	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,620,631	09-2003	Tao et al.	438/9
	C	US-5,858,847	01-1999	Zhou et al.	438/305
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Streetman, Solid State Electronic Devices, 1990, Prentice Hall, 3rd ed., p. 300-301.
	V	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Vol. 1, pp. 384-85.
	W	Wolf, Silicon Processing for the VLSI Era, 2002, Lattice Press, Vol. 4, pp. 145-46.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.